

## Course guide

# 230669 - MEMS - Microelectromechanical Systems

**Last modified:** 11/04/2025

**Unit in charge:** Barcelona School of Telecommunications Engineering  
**Teaching unit:** 710 - EEL - Department of Electronic Engineering.

**Degree:** MASTER'S DEGREE IN ADVANCED TELECOMMUNICATION TECHNOLOGIES (Syllabus 2019). (Optional subject).  
MASTER'S DEGREE IN ELECTRONIC ENGINEERING (Syllabus 2022). (Optional subject).

**Academic year:** 2025    **ECTS Credits:** 5.0    **Languages:** English

### LECTURER

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**Coordinating lecturer:** ANGEL RODRIGUEZ MARTINEZ

**Others:**

### DEGREE COMPETENCES TO WHICH THE SUBJECT CONTRIBUTES

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**Transversal:**

1. EFFECTIVE USE OF INFORMATION RESOURCES: Managing the acquisition, structuring, analysis and display of data and information in the chosen area of specialisation and critically assessing the results obtained.
2. FOREIGN LANGUAGE: Achieving a level of spoken and written proficiency in a foreign language, preferably English, that meets the needs of the profession and the labour market.

### TEACHING METHODOLOGY

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- Lectures
- Application classes
- Individual work (distance)
- Exercises
- Extended answer test (Final Exam)

### LEARNING OBJECTIVES OF THE SUBJECT

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Learning objectives of the subject:

Understanding the general principles and tools of the microelectromechanical systems and devices and its applications.

Learning results of the subject:

- Independent ability to propose, plan and develop MEMS devices and applications
- Ability to understand multidomain problems: thermal, fluidic, mechanical and electrical
- Ability to design a fabrication process of a MEMS device

## STUDY LOAD

Type	Hours	Percentage
Self study	86,0	68.80
Hours large group	39,0	31.20

**Total learning time:** 125 h

## CONTENTS

### (ENG) 1. Introduction to MEMS

**Description:**

- Introduction to MEMS, examples, applications.
- MEMS design and fabrication process outline.
- MEMS for sustainability.

**Full-or-part-time:** 2h

Theory classes: 1h

Self study : 1h

### (ENG) 2. Force scaling

**Description:**

- Scaling of forces to the microworld.
- Examples

**Full-or-part-time:** 5h

Theory classes: 1h

Self study : 4h

### (ENG) 2. Elasticity

**Description:**

- Stress and strain
- Elastic properties of main materials
- Beam equation
- Membranes
- Flexures

**Full-or-part-time:** 16h

Theory classes: 4h

Self study : 12h

#### (ENG) 4. Piezoresistance and piezoelectricity

**Description:**

- Piezoresistance and piezoelectric coefficients
- Pressure sensors based on piezoresistors

**Full-or-part-time:** 18h

Theory classes: 6h

Self study : 12h

#### (ENG) 5. Electrostatic actuation and sensing

**Description:**

- Electrostatic force
- Pull-in and pull-out
- Comb actuators and differential capacitance

**Full-or-part-time:** 16h

Theory classes: 4h

Self study : 12h

#### (ENG) 6. Resonators

**Description:**

- Resonator model
- Equivalent circuit
- Applications

**Full-or-part-time:** 14h

Theory classes: 4h

Self study : 10h

#### (ENG) 7. Inertial sensors

**Description:**

- Accelerometers
- Gyroscopes

**Full-or-part-time:** 15h

Theory classes: 4h

Self study : 11h

#### (ENG) 8. Microfluidics and electrokinetics

**Description:**

- Pressure driven flow
- Electrokinetic flow
- Nanoparticle selfassembly
- Dielectrophoresis
- Liquid lenses and displays

**Full-or-part-time:** 11h

Theory classes: 5h

Self study : 6h



#### (ENG) 9. RF-MEMS

**Description:**

RF-MEMS

**Full-or-part-time:** 11h

Theory classes: 5h

Self study : 6h

#### (ENG) 10. Fabrication processes

**Description:**

- Bulk micromachining
- Surface micromachining
- Foundry services
- Sustainability in MEMS cycle of life

**Full-or-part-time:** 18h

Theory classes: 6h

Self study : 12h

## ACTIVITIES

#### (ENG) THEME WORK

**Description:**

Short bibliographic research work on a topic of interest to the student. Made a summary in technical magazine format and brief presentation in the classroom.

**Full-or-part-time:** 6h

Self study: 6h

#### EXTENDED ANSWER TEST

**Description:**

Final examination.

## GRADING SYSTEM

Class Attendance 10%

Homework consists on deliverables: 40%

..., Problem solving from the problem collection and Tests

..., MEMS world awareness

Course project (Research work, paper writing and ppt) 50%



## BIBLIOGRAPHY

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### Basic:

- Castañer Muñoz, Luis. Understanding MEMS : principles and applications [on line]. Chichester: Wiley, [2016] [Consultation: 07/06/2021]. Available on: <https://ebookcentral.proquest.com/lib/upcatalunya-ebooks/detail.action?docID=4183022>. ISBN 9781119055426.
- Senturia, S.D. Microsystem design [on line]. Boston: Kluwer Academic, 2001 [Consultation: 21/05/2020]. Available on: <http://link.springer.com/book/10.1007/b117574>. ISBN 0792372468.
- Liu, C. Foundations of MEMS. 2nd ed. Essex: Pearson Education Limited, 2012. ISBN 9780273752240.
- Pozar, David M. Microwave engineering [on line]. 4th ed. Hoboken: Wiley, 2012 [Consultation: 07/06/2021]. Available on: <https://ebookcentral.proquest.com/lib/upcatalunya-ebooks/detail.action?docID=2064708>. ISBN 9780470631553.

## RESOURCES

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### Audiovisual material:

- Exemples. Resource

### Hyperlink:

- Transparencies. Resource